

IPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2822  
Examiner: Kevin M. Picardat  
Confirmation No.: 8129

In Re PATENT APPLICATION OF:

Applicant:	Junichi Hikita et al.	)	
Serial No.:	10/748,327	)	
Filed:	December 31, 2003	)	
		)	AMENDMENT
For:	PRODUCTION PROCESS FOR SEMICONDUCTOR DEVICE	)	
		)	
Attny Ref.:	AI 258 D1	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Official Action mailed on June 30, 2005. No fee is due. However, please charge our Deposit Account No. 18-0002 if any fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but please consider this paper a petition for extension of time if needed.

Claims 8 and 9 are canceled without prejudice to reentry. Claim 10 is amended as discussed below, and claims 11 and 12 are typographically corrected. New claims are entered and are patentable for the reasons below.

**FEE ENCLOSED:\$**  
Please charge any further  
fee to our Deposit Account  
No. 18-0002